

Application/Control No.	Applicant(s)/Patent under Reexamination
10/770,886	SEMBO, SATOSHI
Examiner	Art Unit
David P. Stitzel, Esq.	1616

	SEARCHED				
Class	Subclass	Date	Examiner		
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		

SEARCH NOT (INCLUDING SEARCH S		)
	DATE	EXMR
EAST (see updated search notes)	9/5/2006	DPS
STIC (see attached search notes)	9/5/2006	DPS
PALM (updated inventor name search)	9/5/2006	DPS
Allowability Conference held with Sreenivasan Padmanabhan and Alton Pryor	9/5/2006	DPS